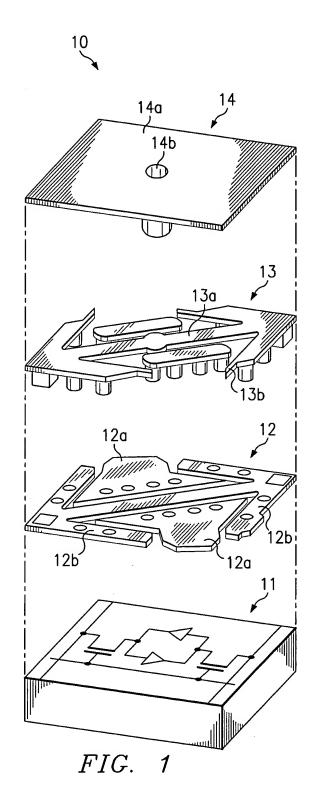
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MEMS STRUCTURE
Inventor: Rabah Mezenner
Attorney Docket: T1-33824
(032350.B550)

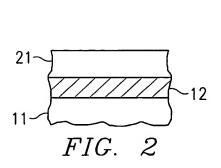
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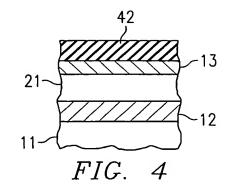


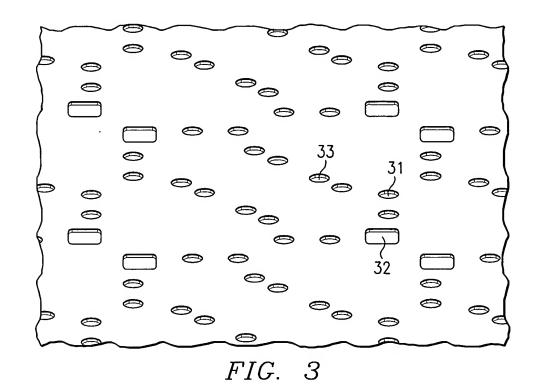
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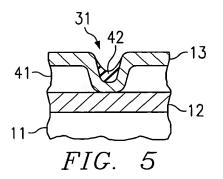
MEMS STRUCTURE Inventor: Rabah Mezenner Attorney Docket: TI-33824 (032350.B550)

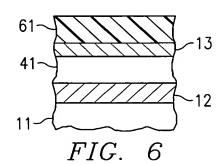
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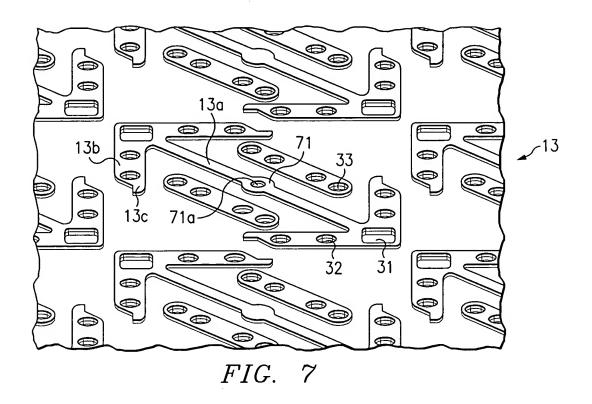


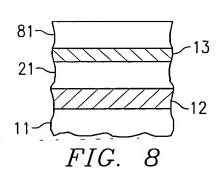


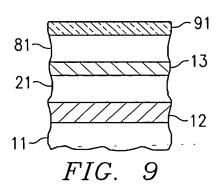
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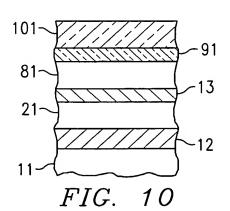
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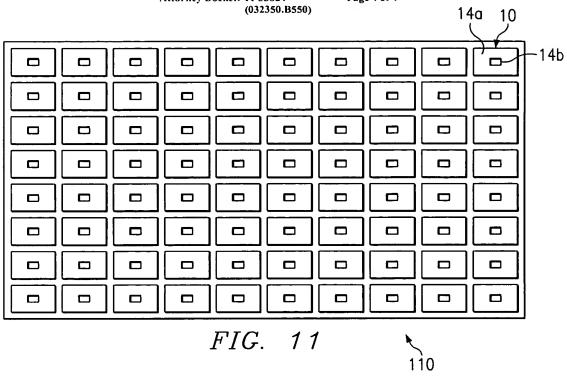






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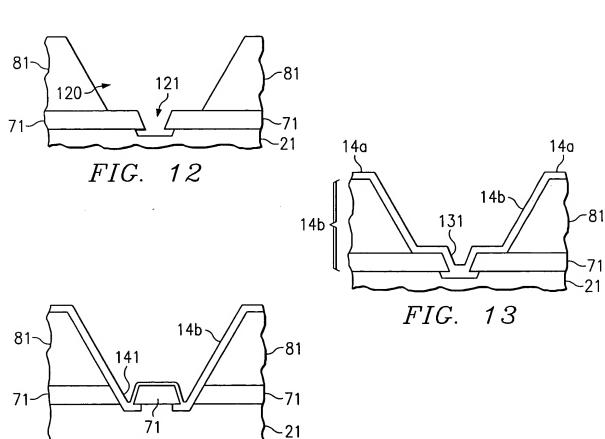


FIG. 14